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	Filing Date		2005-06-27
	First Named Inventor	Menachem Nathan	
	Art Unit	1727	
	Examiner Name	SCULLY, STEVEN M	
	Attorney Docket Number	1082-1007	

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11	PATIL et al., "Issue and challenges facing rechargeable thin film lithium batteries", Materials Research Bulletin, Volume 43, Issues 8-9, pages 1913-1942, August 04 - Sep 04, 2008	<input type="checkbox"/>
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22	CHEAH et al., "Self-Supported Three-Dimensional Nanoelectrodes for Microbattery Applications", NANO Letters, volume 9, issue 9, page 3230, July 02, 2009	<input type="checkbox"/>
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27	OWEN, "Ionically Conducting Glasses", Solid State Batteries, Sequiera and Hooper, Nato Science Series E, Springer, October 1985	<input type="checkbox"/>
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